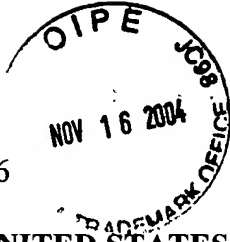


IFW



Docket No.: 65933-056

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
Yoshio OKAYAMA, et al.	:	Confirmation Number: 9924
Application No.: 10/724,111	:	Group Art Unit: 2812
Filed: December 01, 2003	:	Examiner: GURLEY, LYNNE ANN
For: METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE	:	

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following Amendment and Remarks are submitted in response to the Office Action dated July 29, 2004.